



Attorney Docket No: SEL 194

UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Suzawa et al.

Serial No.: 09/615,449

Filed: July 13, 2000

For: Wiring And Manufacturing Method Thereof,
Semiconductor Device Comprising Said
Wiring, And Dry Etching Method

Examiner: H. Trinh

Art Unit: 2814

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

December 3, 2004

Signature Shannon Wallace

Date 12/3/04

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT (F)

In response to the Office Action dated September 9, 2004 and the interview summary of November 18, 2004, please amend the above-identified application as follows: